The 23<sup>rd</sup> Korean Conference on Semiconductors (KCS 2016)

## 제23회 한국반도체학술대회

2016년 2월 22일(월)-24일(수), 강원도 하이원리조트

## D. Thin Film Process Technology 분과

Room B 태백**ᄑ+**ᄑ(5층)

2016년 2월 23일(화) 08:30-10:30

[TB1-D] 1D/2D Materials & Devices

좌장 : 민요셉(건국대학교), 조영진(삼성전자종합기술원)

TB1-D-1	08:30-08:45	Electronic Transport Properties of MoS <sub>2</sub> -pentacene Hybrid p-n Junction Devices Jae-Keun Kim <sup>1</sup> , Kyungjune Cho <sup>1</sup> , Tae-Young Kim <sup>1</sup> , Jinsu Pak <sup>1</sup> , Younggul Song <sup>1</sup> , Barbara Yuri Choi <sup>1</sup> , Woong-Ki Hong <sup>2</sup> , and Takhee Lee <sup>1</sup> <sup>1</sup> Department of Physics and Astronomy, Seoul National University,
		<sup>2</sup> Jeonju Center, Korea Basic Science Institute
TB1-D-2	08:45-09:00	Growth of MoS <sub>2</sub> Thin Films by Atomic Layer Deposition
		Jung Joon Pyeon <sup>1,2</sup> , Cheol Jin Cho <sup>1,3</sup> , Soo Hyun Kim <sup>1</sup> , Chong-Yun
		Kang <sup>1,2</sup> , and Seong Keun Kim <sup>1</sup>
		<sup>1</sup> Center for Electronic materials, Korea Institute of Science and Technology, <sup>2</sup> KU-KIST Graduate school of Converging Science and Technology, <sup>3</sup> Department of Materials Science and Engineering, Seoul National University
TB1-D-3	09:00-09:15	Low-temperature Growth of Wafer-scale Layered MoS <sub>2</sub> by Chemical Vapor Deposition Jihun Mun <sup>1</sup> , Chegal Won <sup>2</sup> , Jeong Won Kim <sup>3</sup> , Taesung Kim <sup>1,4</sup> , and Sang-Woo Kang <sup>2,5</sup> <sup>1</sup> School of Mechanical Engineering, Sungkyunkwan University, <sup>2</sup> Division of Industrial Metrology, Korea Research Institute of Standards and Science, <sup>3</sup> Division of Convergence Technology, Korea Research Institute of Standards and Science, <sup>4</sup> SKKU Advanced Institute of Nanotechnology, Sungkyunkwan University, <sup>5</sup> Department of Advanced Device Technology, University of Science and Technology
TB1-D-4	09:15-09:30	Xenon Flash Lamp-induced Multilayer Graphene Growth for Various Applications Dae Yong Park and Keon Jae Lee Department of Materials Science and Engineering, KAIST
TB1-D-5	09:30-09:45	Two-Dimensional Electron Gas in Oxide Heterostructures using Atomic Layer Deposition Hae Jun Jung and Sang Woon Lee Department of Physics and Division of Energy Systems Research, Ajou University

The 23<sup>rd</sup> Korean Conference on Semiconductors (KCS 2016)

제23회 한국반도체학술대회

2016년 2월 22일(월)-24일(수), 강원도 하이원리조트

TB1-D-609:45-10:00Ultra High-Sensitive Silicon Multi-nanowire Double-Gate Ion-<br/>Sensitive Field-Effect Transistors for Biomolecular Detection<br/>Cheol-Min Lim<sup>1</sup>, In-Kyu Lee<sup>1</sup>, Ki Joong Lee<sup>2</sup>, Young Kyoung Oh<sup>2</sup>,<br/>Yong-Beom Shin<sup>2</sup>, and Won-Ju Cho<sup>1</sup><br/><sup>1</sup>Department of Electronic Materials Engineering, Kwangwoon<br/>University, <sup>2</sup>Korea Research Institute of Bioscience and Bionano<br/>research center